

<b>Form PTO 1449</b>  <b>U.S. Department of Commerce</b> <b>Patent and Trademark Office</b>  Information Disclosure Statement by Applicant	<b>ATTY. DOCKET NUMBER:</b> 10-426 US	<b>SERIAL NUMBER:</b> New application
	<b>APPLICANT:</b> WILLS ET AL.	
	<b>FILING DATE:</b> NEW APPLICATION	<b>GROUP:</b> 2872 NEW APPLICATION

JES03 U.S. PTO  
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**U.S. Patent Documents**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILIN APPR
CNC	4,548,478	Oct. 22/85	Shirasaki	350	377	
CNC	6,212,008	Apr. 3/01	Xie et al.	359	484	
CNC	6,175,448	Jan. 16/01	Xie et al.	359	497	
CNC	6,014,256	Jan. 11/00	Cheng	359	495	
CNC	4,239,329	Dec. 16/80	Matsumoto	350	96.15	
CNC	5,204,771	Apr. 20/93	Koga	359	281	
CNC	4,178,073	Dec. 11/79	Uchida et al.	350	151	

**Foreign Patent Documents**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
			NONE				

**Other Documents (Including Author, Title, Date Pertinent Pages, Etc.)**

CNC		"Yttrium Vanadate (YV04) Crystal – Special Crystal for Fiber Optics" pp. 1-3				
CNC		"MTI Corporation – A Single Source for All Single Crystal Substrates" pp. 1-8				
<table border="1"> <tr> <td>EXAMINER</td> <td>Craig H. Curtis</td> <td>DATE CONSIDERED</td> <td>28 July 2002</td> </tr> </table>			EXAMINER	Craig H. Curtis	DATE CONSIDERED	28 July 2002
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EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP 609; draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant						